



Attorney Docket No. 0553-0295

28/2
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Koichiro TANAKA et al

Serial No.: 10/034,022

Filed: December 20, 2001

Art Unit: 2812

For: METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE

I hereby certify that this correspondence
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Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, on October 4,
2004

Cristie M. Hall

Date: October 4, 2004

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §1.97, as revised on February 4, 1992, 1135 OG 23-24, Applicant hereby calls the Examiner's attention to documents listed on the attached form, which documents may be material to the examination of this application. Copies of the references are enclosed herewith for the Examiner's consideration.

The family of CN 1003899 cited herein includes:

US Patent no. 4,713,518
US Patent no. 4,874,920
US Patent no. 4,970,368
US Patent no. 4,970,369

No inference should be drawn that the attached list sets forth a comprehensive investigation of the prior art, that any or all are pertinent to the invention, or that any apparatus disclosed is equivalent to the subject invention.

The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

The references disclosed herein were cited in Chinese Patent Office, Office Action dated July 9, 2004, in counterpart Chinese application no. 001125338X. As this is being submitted within three months, Applicant does not believe that a fee is due. However, if any such fee is required, please charge our Deposit Account No. 50/1039.

Respectfully submitted,



Mark J. Murphy
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LIST OF PUBLICATIONS
CITED BY APPLICANT

Atty. Docket No.
SEL 295

Serial No.
10/034,022

Applicant
Koichiro TANAKA et
al

Filing Date
December 20, 2001

Group
2812

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	4,713,518	12/15/87	Yamazaki et al	219	121	06/03/85
	4,874,920	10/17/89	Yamazaki et al	219	121.85	01/13/89
	4,970,368	11/13/90	Yamazaki et al	219	121.85	04/06/89
	4,970,369	11/13/90	Yamazaki et al	219	121.85	04/06/89

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	APPLICANT	English Abstract	English Trans.	FILING DATE
	CN 1003899 B	04/12/89	Handotai Energy Kenkyusho	X		06/28/85

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

(Include name of author (in CAPITAL LETTERS), title of article or item (book, magazine, journal, serial, symposium, catalog, etc.) date, pages(s), volume-issue number(s), publisher, city and/or country where published).

EXAMINER:

DATE CONSIDERED:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.